In re application of		)
	Yongjun Hu	)
Serial No.:	10/771,828	) Art Unit
Filed:	February 4, 2004	) 2818
Confirmation No.:	3960	)
For:	PROCESS FOR FORMING A DIFFUSION BARRIER MATERIAL NITRIDE FILM	)
Examiner:	Quoc Hoang	)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## **AMENDMENT AND RESPONSE**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed from the United States Patent and Trademark Office on May 24, 2004, please enter the following remarks into the file of the above-identified application.